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| APPLICATION NO.                                            | FILING DATE    | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO.        | CONFIRMATION NO. |
|------------------------------------------------------------|----------------|----------------------|----------------------------|------------------|
| 10/725,848                                                 | 12/02/2003     | Diane C. Boyd        | YOR920030335US1<br>(16900) | 3237             |
| 23389 75                                                   | 590 10/06/2005 | •                    | EXAMINER                   |                  |
| SCULLY SCOTT MURPHY & PRESSER, PC<br>400 GARDEN CITY PLAZA |                |                      | GEORGE, PATRICIA ANN       |                  |
| SUITE 300                                                  | OH I I LINEAR  |                      | ART UNIT                   | PAPER NUMBER     |
| GARDEN CIT                                                 | Y, NY 11530    |                      | 1765                       |                  |
|                                                            |                |                      | DATE MAILED: 10/06/2005    | 5                |

Please find below and/or attached an Office communication concerning this application or proceeding.

| •                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                      |                                                                                                                                                     |                                                                                                                       | 6/-              |
|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------|------------------|
| . (                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                    | Application No.                                                                                                                                     | Applicant(s)                                                                                                          | <del>``</del> E/ |
| ,                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                      | 10/725,848                                                                                                                                          | BOYD ET AL.                                                                                                           |                  |
| Office Action Summary                                                                                                                                                                                                                                                                                                                                                                                                                                                                                  | Examiner                                                                                                                                            | Art Unit                                                                                                              |                  |
|                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                        | Patricia A. George                                                                                                                                  | 1765                                                                                                                  |                  |
| The MAILING DATE of this communication a<br>Period for Reply                                                                                                                                                                                                                                                                                                                                                                                                                                           | appears on the cover sheet w                                                                                                                        | vith the correspondence address                                                                                       | :                |
| A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING  - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period.  - Failure to reply within the set or extended period for reply will, by stat Any reply received by the Office later than three months after the ma earned patent term adjustment. See 37 CFR 1.704(b). | DATE OF THIS COMMUN<br>1.136(a). In no event, however, may a<br>od will apply and will expire SIX (6) MC<br>tute, cause the application to become a | ICATION.  The reply be timely filed  ONTHS from the mailing date of this communication.  ABANDONED (35 U.S.C. § 133). |                  |
| Status                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                 |                                                                                                                                                     |                                                                                                                       |                  |
| 1)⊠ Responsive to communication(s) filed on <u>02</u>                                                                                                                                                                                                                                                                                                                                                                                                                                                  | December 2003.                                                                                                                                      |                                                                                                                       |                  |
|                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                        | nis action is non-final.                                                                                                                            |                                                                                                                       |                  |
| 3) Since this application is in condition for allow                                                                                                                                                                                                                                                                                                                                                                                                                                                    |                                                                                                                                                     | tters, prosecution as to the meri                                                                                     | its is           |
| closed in accordance with the practice unde                                                                                                                                                                                                                                                                                                                                                                                                                                                            | ·                                                                                                                                                   | •                                                                                                                     |                  |
| Disposition of Claims                                                                                                                                                                                                                                                                                                                                                                                                                                                                                  |                                                                                                                                                     |                                                                                                                       |                  |
| 4)⊠ Claim(s) 1-30 is/are pending in the application                                                                                                                                                                                                                                                                                                                                                                                                                                                    | on.                                                                                                                                                 |                                                                                                                       |                  |
| 4a) Of the above claim(s) is/are withd                                                                                                                                                                                                                                                                                                                                                                                                                                                                 |                                                                                                                                                     |                                                                                                                       |                  |
| 5) Claim(s) is/are allowed.                                                                                                                                                                                                                                                                                                                                                                                                                                                                            |                                                                                                                                                     |                                                                                                                       |                  |
| 6)⊠ Claim(s) <u>1-27</u> is/are rejected.                                                                                                                                                                                                                                                                                                                                                                                                                                                              |                                                                                                                                                     |                                                                                                                       |                  |
| 7) Claim(s) is/are objected to.                                                                                                                                                                                                                                                                                                                                                                                                                                                                        |                                                                                                                                                     |                                                                                                                       |                  |
| 8) Claim(s) <u>28-30</u> are subject to restriction and                                                                                                                                                                                                                                                                                                                                                                                                                                                | or election requirement.                                                                                                                            |                                                                                                                       |                  |
| Application Papers                                                                                                                                                                                                                                                                                                                                                                                                                                                                                     |                                                                                                                                                     |                                                                                                                       |                  |
| 9)☐ The specification is objected to by the Exami                                                                                                                                                                                                                                                                                                                                                                                                                                                      | ner.                                                                                                                                                |                                                                                                                       |                  |
| 10) The drawing(s) filed on is/are: a) a                                                                                                                                                                                                                                                                                                                                                                                                                                                               | ccepted or b) objected to                                                                                                                           | by the Examiner.                                                                                                      |                  |
| Applicant may not request that any objection to the                                                                                                                                                                                                                                                                                                                                                                                                                                                    | ne drawing(s) be held in abeya                                                                                                                      | ance. See 37 CFR 1.85(a).                                                                                             |                  |
| Replacement drawing sheet(s) including the corre                                                                                                                                                                                                                                                                                                                                                                                                                                                       | ection is required if the drawin                                                                                                                    | g(s) is objected to. See 37 CFR 1.1                                                                                   | 21(d).           |
| 11)☐ The oath or declaration is objected to by the                                                                                                                                                                                                                                                                                                                                                                                                                                                     | Examiner. Note the attache                                                                                                                          | ed Office Action or form PTO-15                                                                                       | 2.               |
| Priority under 35 U.S.C. § 119                                                                                                                                                                                                                                                                                                                                                                                                                                                                         |                                                                                                                                                     |                                                                                                                       |                  |
| 12) Acknowledgment is made of a claim for foreignal All b) Some * c) None of:                                                                                                                                                                                                                                                                                                                                                                                                                          | gn priority under 35 U.S.C.                                                                                                                         | § 119(a)-(d) or (f).                                                                                                  |                  |
| 1. Certified copies of the priority docume                                                                                                                                                                                                                                                                                                                                                                                                                                                             | ents have been received.                                                                                                                            |                                                                                                                       |                  |
| <ol><li>Certified copies of the priority docume</li></ol>                                                                                                                                                                                                                                                                                                                                                                                                                                              | ents have been received in                                                                                                                          | Application No                                                                                                        |                  |
| <ol><li>Copies of the certified copies of the pr</li></ol>                                                                                                                                                                                                                                                                                                                                                                                                                                             | iority documents have bee                                                                                                                           | n received in this National Stage                                                                                     | Э                |
| application from the International Bure                                                                                                                                                                                                                                                                                                                                                                                                                                                                | , , , ,                                                                                                                                             | ·                                                                                                                     |                  |
| * See the attached detailed Office action for a li                                                                                                                                                                                                                                                                                                                                                                                                                                                     | st of the certified copies no                                                                                                                       | t received.                                                                                                           |                  |
|                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                        |                                                                                                                                                     |                                                                                                                       |                  |
| Attachment(s)                                                                                                                                                                                                                                                                                                                                                                                                                                                                                          |                                                                                                                                                     |                                                                                                                       |                  |
| 1) Notice of References Cited (PTO-892)                                                                                                                                                                                                                                                                                                                                                                                                                                                                |                                                                                                                                                     | Summary (PTO-413)                                                                                                     |                  |
| 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)                                                                                                                                                                                                                                                                                                                                                                                                                                            |                                                                                                                                                     | (s)/Mail Date Informal Patent Application (PTO-152)                                                                   |                  |
| Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0     Paper No(s)/Mail Date                                                                                                                                                                                                                                                                                                                                                                                                                    | 6) Other:                                                                                                                                           | •                                                                                                                     |                  |

#### **DETAILED ACTION**

### Election/Restrictions

Claims 28-30 are withdrawn from further consideration pursuant to 37 CFR 1.142(b) as being drawn to nonelected group II, drawn to product, there being no allowable generic or linking claim. Election was made without traverse in the reply filed on 8/29/05.

### Specification

The specification is objected to as failing to provide proper antecedent basis for the claimed subject matter. See 37 CFR 1.75(d)(1) and MPEP § 608.01(o). Correction of the following is required: Claim 6 recites the limitation " implant energy of 1x10<sup>14</sup> atoms/cm<sup>2</sup> to 2x10<sup>18</sup> atoms/cm<sup>2</sup>", which is not found in the specification. There is insufficient antecedent basis for this limitation in the claim.

The lengthy specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Application/Control Number: 10/725,848

Art Unit: 1765

### Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1-2, 4-5, 6-8, 12, 20, 24, and 26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott et al. of US 6,486,037 in view of Sugihara et al. of US 6,566,734.

As for claim 1, see figures 5a-c, where Norcott et al. disclosed the process of making a buried oxide region utilizing a low dose oxygen implant step (ab.) (commonly known as SIMOX) providing: a SOI substrate having an SOI layer located on a buried insulating layer (col.4, I.48); forming a block mask having a channel via atop said SOI substrate (col.4, I.30-35); a self-aligned, localized oxide region (col.4, I.47) in SOI layer on top of said buried insulating layer which forms a thinned portion of said SOI layer (col.6, I.12-13); and removing block mask (col.7, I.65-67).

As for claim 2, Norcott et al. disclosed implanting oxygen dopant via a patterned channel to dope a portion of said SOI layer (col.4, l.66-67); and annealing the substrate

to convert the doped region into an oxide region that is on top of and in contact with a buried insulating layer providing a thin portion of the SOI layer (col.6, I.35-46).

As for claim 4, Norcott et al. disclosed the SOI layer comprises isolation regions in figure 5c.

As for claim 5, Norcott et al. disclosed an oxygen dopant is implanted with a dose of about  $1 \times 10^{17}$  cm<sup>-2</sup> or above (col.2, l. 60-61).

As for claim 6, Norcott et al. disclosed an oxygen dopant is implanted with an implant energy ranging from 20 to 400 KeV.

As for claim 7, Norcott et al. disclosed an oxygen dopant is implanted having a current beam density ranging from about 0.5 to 500 mA cm2 which encompasses the claimed range of 5.0 mA cm.sup.-2 to about 10.0 mA cm.sup.-2. See column10, lines 61-62.

As for claim 8, Norcott et al. disclosed an SOI layer comprises Si, SiGe, SiGeC, SiC or combinations thereof (col.4, l.40-45).

Norcott et al. failed to openly disclose the claimed limitations toward methods of forming: (1) source/drain extensions in regions doped with IIIA or V dopants (col.11, I.35-40); and (2) gate in via channel, as in claims 1, 12, 20, 24, and 26. Norcott et al. failed to disclose: (1) forming a block mask having a channel via atop said SOI substrate; forming a gate in said channel via; removing at least said block mask (as in claim 1); forming a dummy gate region atop said material stack; forming a masking layer substantially coplanar with a top surface of said dummy gate region; removing said dummy gate region to produce said block mask having said channel via; and

forming a conformal film atop said block mask and within said channel via (as in claim 12); etching horizontal surfaces of said conformal film and said material stack to expose said SOI layer; forming a gate conductor atop said gate dielectric and removing said block mask (as in claim 20); gate conductor material is polysilicon (as in claim 24); and (2) forming source/drain extensions (as in claim 1), with a thickness of about 20.0 nm to about 70.0 nm (as in claim 26).

However, Norcott did teach SOI devices and circuits, such as microprocessors, memory cells, advanced integrated circuits, and even more complicated circuits (col.8, I.14-20), which all contain said structures (1 and 2).

Sugihara et al. teaches well known, conventional methods of forming a field effect transistor (FET), including: (1) the forming of source/drain extension regions (ab.), as in claim 1: doped with arsenic or phosphorous, from the claimed groups of IIIA or V dopants (col.11, I.35-40), as in claim 26; and (2) the forming of gate (ab.) in via channel, as in claim 1: forming a dummy gate region (ab.) on a material stack (fig.2); forming a masking layer, coplanar to the gate (col.8, I1-4); removing the dummy gate (col.8, I.61-62) to produce said block mask (col.8, l.64-65); and forming a conformal film over and within the channel (fig. 3 or 6), as in claim 12. Also see figures 14 then 15, which shows sequential steps of forming gate electrode by forming a gate dummy followed by the block mask method and, as in claim 12. Further, Sugihara also teaches forming the gate in the channel provides: etching horizontal surfaces of said conformal film and the material stack to expose said SOI layer (see figure 8); forming a gate dielectric atop

said SOI layer (col.9, I55 and figure 12, 17); forming a gate conductor atop said gate dielectric (col.9, I.54-55), as in claims 20 and 24.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include the structural methods of forming conventional, commonly used semiconductor source/drain extension regions, and gates, as Sugihara, after making a SIMOX substrate for semiconductor devices, as Norcott, because the methods are well known and conventional.

## Claim Rejections - 35 USC § 103

Claims 3 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott et al. and Sugihara et al. (see discussion above) in further view of Dolan et al. of US 6,417,078.

Norcott fails to teach the following properties of the SOI region: the thickness of the SOI layer 20.0 nm to about 70.0 nm, as in claim 3; and the thinning of a portion of the region, as in claim 9.

Dolan teaches a process improvement to SIMOX, comprising a range of SOI layer thickness from about 10 to 250 nm (ab.) which encompasses the claimed range of 20.0 nm to about 70.0 nm, as in claim 3.

Dolan also teaches the localized oxide region thins a portion of the SOI layer to 30 to 300 nm (col.3, l.65-67), which encompasses the claimed range of less than about 50.0 nm, as in claim 9.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to select the thicknesses of the SOI region, both SOI layer and localized oxide region, in the modified method of Norcott et al., because the reference of Dolan teaches such thicknesses are desirable for a process improvement which enhances the performance of devices manufactures on SOI structures.

### Claim Rejections - 35 USC § 103

Claims 10, and 11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott et al. and Sugihara et al. (see discussion above) in further view of Yiu et al. of US 2003/0186511.

Norcott et al. disclosed forming a material stack on a SOI substrate prior to forming a block mask (see fig. 5a-c), as in claim 10.

Norcott et al. failed to disclose including a pad oxide layer positioned on the SOI layer, and a silicon nitride (Si3N4) etch stop layer positioned on the pad oxide layer.

Yiu teaches a conventional layering technique used over the isolation area includes: a pad oxide layer positioned on the SOI layer, and a silicon nitride (Si3N4) etch stop layer positioned on the pad oxide layer (para. 1-11), as in claims 10 and 11.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include subsequent layers when forming a field effect transistor with SIMOX, as combined by Norcott et al. and Sugihara, because Yiu teaches it is known and conventional.

### Claim Rejections - 35 USC § 103

Claims 15, and 21 - 23 are rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott, Sugihara, and Yiu (see discussions above) in further view of Adkisson et al of US US 2002/0153587.

The combined teachings of Norcott and Sugihara illustrates the gate conductor is formed over the gate mask and dielectric, and planarizing until the gate conductor material is coplanar with the block mask (see figure 12), as in claim 22.

Norcott and Sugihara forming a conformal film over and within the channel (fig. 3 or 6), as in claim 15, but fail to teach the conventional limitations of claims 15, and 21-23.

Adkisson teaches widely known conventional semiconductor fabrication techniques, such as: etching of regions of a layer not underlying said patterned photoresist, as in claim 15 (figure 3A, and para 52); the forming of a gate dielectric by thermal oxidation (para. 53), as in claims 21 and 22; etching silicon nitride selective to pad oxide layer, as in claim 23 (para. 70, l.6); and etching pad oxide layer with a RIE comprising HF and NH.sub.3, as in claim 23 (para. 66).

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to use the conventional limitations of thermal oxidation, selective etching, and RIE chemistry, of Adkisson et al., when forming the combined semiconductor invention, above, because it is obvious to use such widely known conventional techniques.

# Claim Rejections - 35 USC § 103

Claim 13 is rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott et al., Sugihara et al., and Yiu et al. (see discussions above) in further view of Lim et al. of US 6,673, 695.

Norcott was silent as to method of HD deposition of an oxide mask layer.

As for claim 13, Lim et al. teaches the widely available method of HD deposition of an oxide mask layer (col. 5, I.40), as in claims 13.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to use the method of HD, of Lim, to deposit the oxide mask, when forming a semiconductor, as above, because use of HDP for an oxide mask is widely available.

### Claim Rejections - 35 USC § 103

Claims 14 and 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott et al., Sugihara et al., and Yiu et al. (see discussions above) in further view of Miyakawa et al. of US 6,162,677.

Norcott was silent as to the limitations of silicon nitride in claims 14 and 15.

Miyakawa et al. teaches known and industry used methods for silicon nitride etch stop (col.8, I.56) formed by a CVD process (col.8, I.60), having a thickness of 50 nm (col.8, I.54-65) within the claimed ranging from about 50.0 nm to about 150.0 nm, as in claims 14 and 15.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include the SiN methods of Miyakawa, when forming a semiconductor, as above, because Miyakawa methods are known and used.

### Claim Rejections - 35 USC § 103

Claims 16, 18, and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott, Sugihara, Yiu, and Miyakawa (see discussions above) in further view of Tan of US 6,001,706.

Norcott is silent as to polysilicon etch, including plasma etch with HBr, or wet etch with KOH chemistries.

Tan et al. teaches conventionally used methods for polysilicon etch, including plasma etches with HBr, or wet etch with KOH chemistries, as in claims 16, 18, and 19.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include the conventionally used polysilicon etches, of Tan, when forming a semiconductor, as above, because they are conventional.

#### Claim Rejections - 35 USC § 103

Claim 17 is rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott, Sugihara, Yiu, and Miyakawa (see discussions above) in further view of Graas of USPN 5,360,995.

Notrcott is silent as to removal of photo resist using an O.sub.2 ash process.

Graas teaches the widely used, known, common method for removal of photo resists using an O.sub.2 ash process, as in claim 17 (col. 5-6, l. 67-1), as in claim 17.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include the conventionally ash for polysilicon, of Graas, when forming a semiconductor, as above, because it is a widely used, known, common method.

### Claim Rejections - 35 USC § 103

Claim 25 is rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott, Sugihara, Yiu, and Miyakawa (see discussions above) in further view of Yang et al. of US 6,110,779.

Norcott is silent as to doping the polysilicon prior to removing a hard mask.

Yang teaches a conventional method for doping polysilicon with use of a hard mask, which is written on prior to removing a hard mask. (col.4, I. 6-8), as in claim 25.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include the conventional method of doping polysilicon, of Yang, when forming a semiconductor, as above, because the method is conventional.

### Claim Rejections - 35 USC § 103

Claim 27 is rejected under 35 U.S.C. 103(a) as being unpatentable over Norcott, Sugihara, Yiu, and Miyakawa (see discussions above) in further view of Suguro et al. of US 6,465,290.

Norcott fails to teach source/drain extension regions having a thickness of about 20.0 nm to about 70.0 nm.

Suguro et al. teaches a process improvement of source/drain extension regions having a thickness of about 20.0 nm to about 70.0 nm (col.18, l.57-61), as in claim 27.

It would have been obvious to one of ordinary skill in the art at the time of invention was made, to include the process improvement, of Suguro, when forming a semiconductor, as above, because it is a cost savings to improve the process.

#### Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure: US 6,300,218; US 6,064,092; US 6,479,866; US 6,959,331; US 6,010,921; US 6,531,741; US 6,022,768.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Patricia A. George whose telephone number is (571) 272-5955. The examiner can normally be reached on weekdays between 7:00am and 4:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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PAG 09/05 Patricia A George Examiner Art Unit 1765

CAPERVISORY FAIL NORTON